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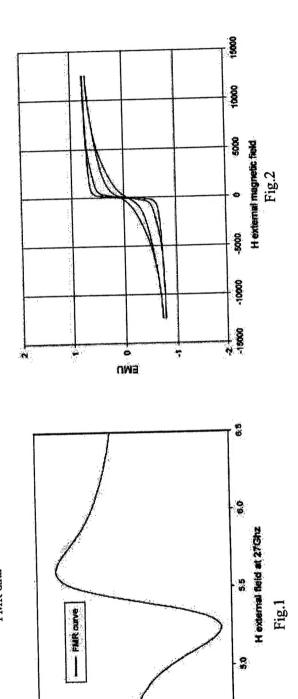
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11. SUPPLEMENTARY NOTES The views, opinions and/or findings contained in this report are those of the author(s) and should not be construed as an official Department of the Army position, policy or decision, unless so designated by other documentation.	
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13. ABSTRACT (Maximum 200 words)	
We have developed a technique to orient particles of Y-type hexaferrite in which the c-axis of the particles are	oriented
perpendicular to a plane. As such, that plane becomes necessarily the easy plane of magnetization. For microwave device apprette easy plane of magnetization is chosen as the plane to deposit a metallic microstrip and related circuit patterns. The te	chnique
I entails the rotation of an external magnetic field in the easy plane, as the particles are pressed into a disc snape. We have succe	eaca on p
the orientation of particles of Ba ₂ MnZnFe ₁₂ O ₂₂ in an easy plane of magnetization which exhibited the following pro-	opernes:
$4\pi Ms = 2300$ Oe, Ha = 9500Oe, and Hc = 60Oe, where $4\pi Ms$ is the saturation magnetization, Ha the uniaxial anisotropy field the coercive field. The coercive field and remanence can be varied by refiring the oriented particles. Maximum remanence	of 27.5
1 % was obtained for refiring temperature of 1000 C. Much higher remanence is possible for thin film plane structure, where in	e aspect
ratio exceeding 1000. These results imply that it is possible to orient the saturation magnetization in any direction within the pl	ane of a
device and the effective magnetization can be as high as 11800 Oe. The microwave properties indicate that the ferrin resonance linewidth at 27 GHz is 350 Oe and the g-factor approximately equal to 2, see fig .1. In fig.2 the vibrating	sample
magnetization (VSM) measurements for ZnMnY-type are shown for the external field applied parallel and perpendicular to ear	sy piane
of magnetization. We have also been working on Co2Y-type, our experiments show 4πMs=2.2kOe, Ha=42 kOe and linewidth	around
2000Oe at 38 Ghz. Potential microwave applications are fabrication of IC circuits and microwave ferrite devices.	
14. SUBJECT TERMS Hexaferrite, Orientation, and Ceramic. 15. NUMBER OF PAGES 1	
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Oriented Y-type Hexaferrites for ferrite devices

factor approximately equal to 2, see fig. 1. In fig.2 the vibrating sample magnetization (VSM) measurements for ZnMnY-type are shown external magnetic field in the easy plane, as the particles are pressed into a disc shape. We have succeeded on the orientation of particles for the external field applied parallel and perpendicular to easy plane of magnetization. We have also been working on Co2Y-type, ours We have developed a technique to orient particles of Y-type hexaferrite in which the c-axis of the particles are oriented perpendicular to of 1000 C. Much higher remanence is possible for thin film plane structure, where the aspect ratio exceeding 1000. These results imply that it is possible to orient the saturation magnetization in any direction within the plane of a device and the effective magnetization can magnetization is chosen as the plane to deposit a metallic microstrip and related circuit patterns. The technique entails the rotation of an and remanence can be varied by refiring the oriented particles. Maximum remanence of 27.5 % was obtained for refiring temperature Hc = 60Oe, where 4πMs is the saturation magnetization, Ha the uniaxial anisotropy field and Hc the coercive field. The coercive field a plane. As such, that plane becomes necessarily the easy plane of magnetization. For microwave device application the easy plane of of $Ba_2MnZnFe_{12}O_{22}$ in an easy plane of magnetization which exhibited the following properties: $4\pi Ms=2300$ Oe, Ha=95000e, and be as high as 11800 Oe. The microwave properties indicate that the ferrimagnetic resonance linewidth at 27 GHz is 350 Oe and the gexperiment shows 4πMs=2.2kOe, Ha=42 kOe and linewidth around 2000Oe at 38 Ghz. Potential microwave applications are in the Northeastern University, Boston, MA 02115 M. Obol, X. Zuo, T. Sakai and C. Vittoria. fabrication of IC circuits and microwave ferrite devices.



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